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By: 

Date: April 11, 2003

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GROUP 1700
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Harald Richter et al.
Applic. No. : 09/917,549
Filed : July 27, 2001
Title : Method of Processing Organic Antireflection Layers
Examiner : Allan W. Olsen
Group Art Unit : 1763

Supplemental Response

Hon. Commissioner of Patents and Trademarks,
Washington, D. C. 20231

S i r :

Responsive to the Office communication dated March 11, 2003
and further to the amendment filed December 26, 2002 in
response to the Office action dated September 25, 2002, kindly
consider the following remarks:

Remarks:

Reconsideration of the application is requested.